



IFW SP AF/1742

PATENT
Atty. Dkt. No. AMAT/6089.P1/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:
Kholodenko

Serial No.: 10/061,126

Confirmation No.: 2260

Filed: January 30, 2002

For: Method And Apparatus For
Encapsulation of An Edge of A
Substrate During An
Electrochemical Deposition
Process

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

§§§§§ Group Art Unit: 1742

§§§§§ Examiner: Wesley A. Nicolas

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on
5/12, 2004, with the United States Postal Service
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5/12/04
Date

Kristen Zabel
Signature

RESPONSE TO FINAL OFFICE ACTION DATED MARCH 12, 2004

In response to the Final Office Action dated March 12, 2004, having a shortened statutory period for response set to expire on June 12, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6089.P1, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.